

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Paul A. Farrar

Title: METHOD OF CLEANING SEMICONDUCTOR SURFACES

Docket No.: 1303.112US1

Serial No.: 10/681,481

Filed: October 8, 2003

Due Date: November 26, 2007

Examiner: Michail Kornakov

Group Art Unit: 1746

MS AF

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

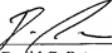
We are transmitting herewith the following attached items (as indicated with an "X"):

- Amendment and Response (12 pgs.).
 Petition for Extension of Time (1 pg.).
 Authorization to charge Deposit Account 19-0743 in the amount of \$120.00 to cover the Extension of Time Fee.

If not provided for in a separate paper filed herewith, Please consider this a PETITION FOR EXTENSION OF TIME for sufficient number of months to enter these papers and please charge any additional fees or credit overpayment to Deposit Account No. 19-0743.

SCHWEGMAN, LUNDBERG & WOESSNER, P.A.

Customer Number 21186

By: 
Atty. David C. Peterson
Reg. No. 47,857

CERTIFICATE UNDER 37 CFR 1.8: The undersigned hereby certifies that this correspondence is being filed using the USPTO's electronic filing system EFS-Web, and is addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on this 26 day of November, 2007.

Lisa Rosarske
Name

Lisa Rosarske
Signature

SCHWEGMAN, LUNDBERG & WOESSNER, P.A.

(GENERAL)